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TOLERANCES			П		DDV CVCTEMC	DESCRIPTION			NO REQ'D	Г
Linear unless noted					DRY SYSTEMS	DOUBL	E CHECK VALVE		1	5
	ı					SCALE	DATE	DRAWN BY		ь
Machined: ±0.005					TECHNOLOGIES	Full	July 23,2019	W Fox		
Fabricated: ±0.02					10420 RISING COURT	MATERIAL APPROVED BY			Ы	
Angular: ±1/2°					WOODRIDGE, IL 60517	DRAWING NO			٠,	
Surface finish 125			Г		Phone: 630-427-2051 Fax: 630-427-1036	M350-896-01				
Sulface Illish 123	REV	DATE	NAME	DESCRIPTION	E-Mail: eng@drysystemstech.com		111000 00	 		